

5G Electronics: bridging the measurements challenges

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Outline

- ❑ Modelling-based resonant material characterisation techniques for 5G and other emerging technologies.
- ❑ Broadband mm-wave characterisation of materials.
- ❑ iNEMI Project Tasks
- ❑ Advances in resonator-based characterisation techniques – application to project tasks.
- ❑ Conclusions & outlook.

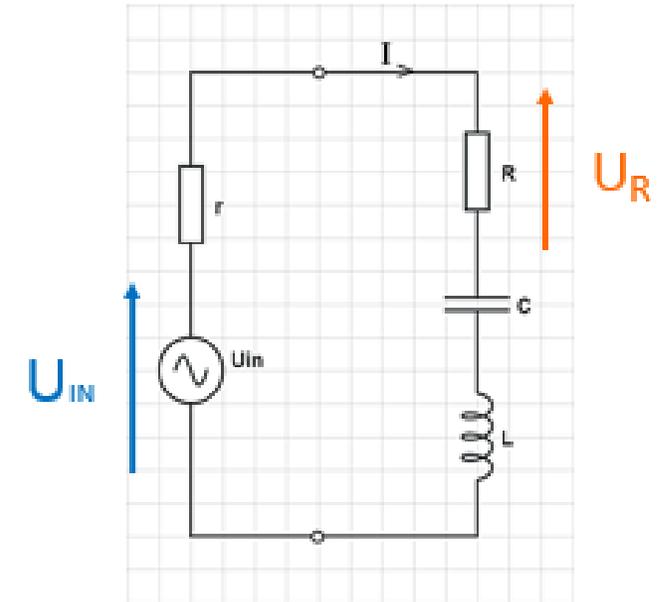
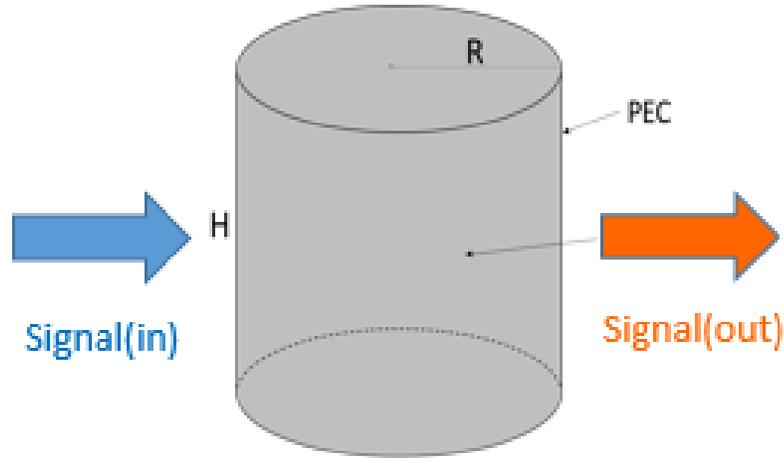
Modelling – based characterisation of materials for emerging technologies

Focus on resonant methods:

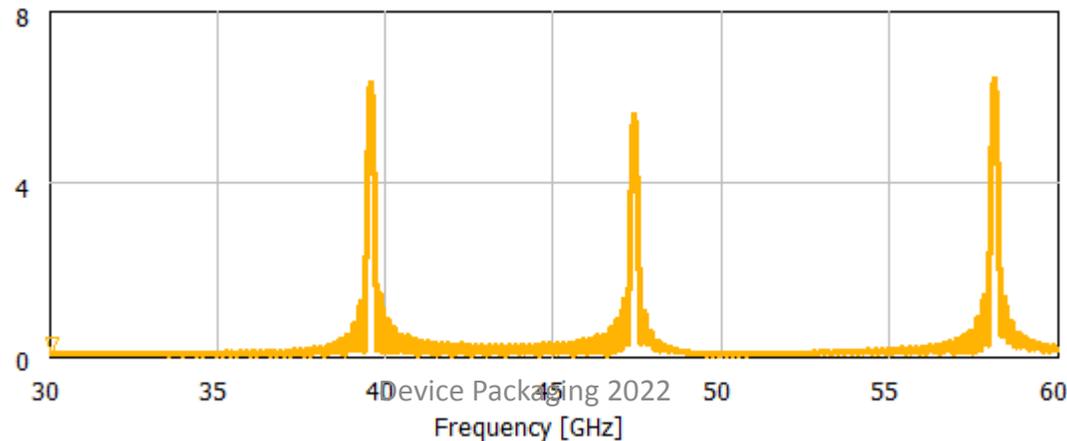
- proven ultra-high accuracy in GHz range
- dedicated to low-loss & low-resistivity materials (both, bulk and thin sheets)
- ease-of-use
- available on the market
- repeatability & reproducibility for 5G under iNEMI project studies

Resonator methods – motivation and background (1)

Resonance in practice: given fixed strength of **Signal(in)**, at resonance **Signal (out)** is strongest



$\delta(t)$

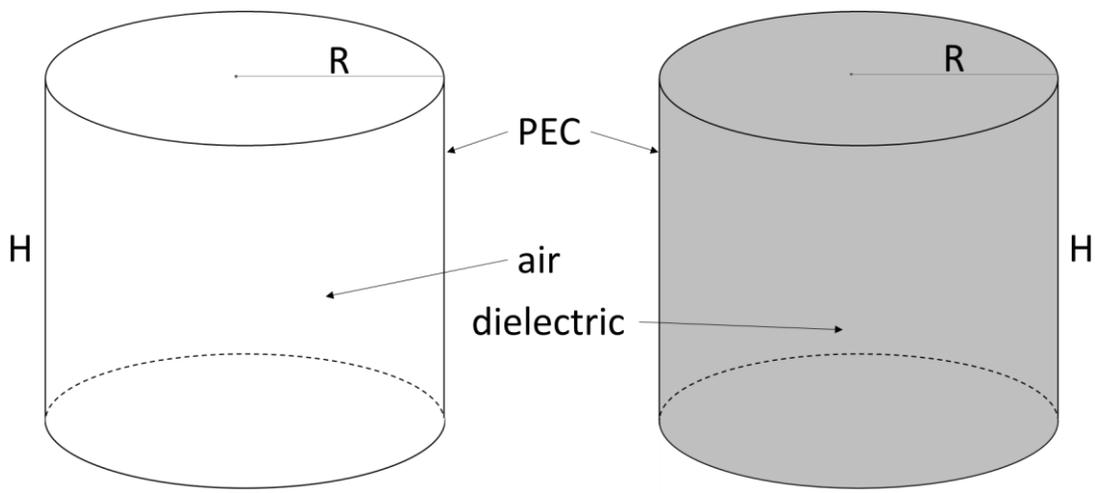


Resonator methods – motivation and background (2)

Resonance in theory: non-zero electromagnetic fields (modes) exist in isolated structures (no excitation).

Field properties are well-defined and **linked to material properties**.

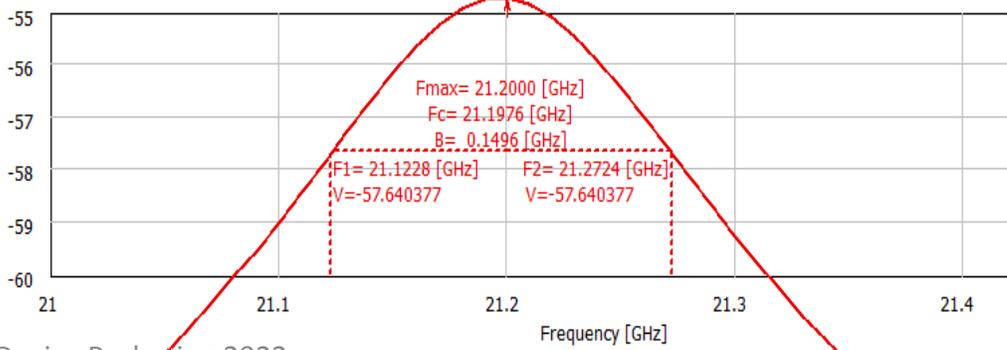
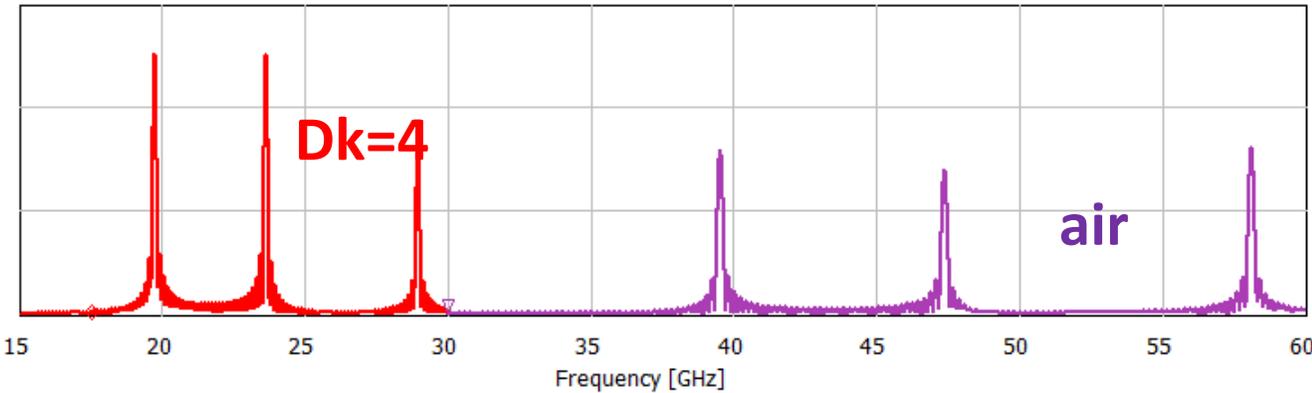
E.g. for **cylindrical** cavities:



$$f_{r,mnp} = \frac{c}{\sqrt{Dk}} \sqrt{\left(\frac{\kappa_{mn}^{(j)}}{\pi R}\right)^2 + \left(\frac{p}{H}\right)^2}$$

in non-magnetic low-loss dielectrics

$$Q = 2\pi \frac{\iiint_V \epsilon \vec{E} \cdot \vec{E}^* dv}{T \iiint_V \sigma \vec{E} \cdot \vec{E}^* dv} = \frac{\omega \epsilon}{\sigma} = \frac{1}{Df} \approx \frac{fres}{\Delta f}$$

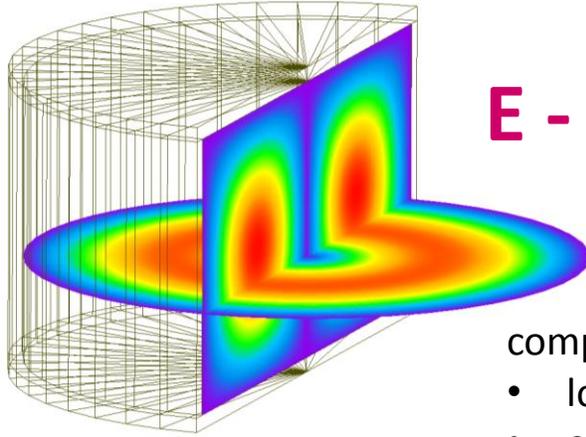


Analytical solutions are for **eigenvalue** problems.

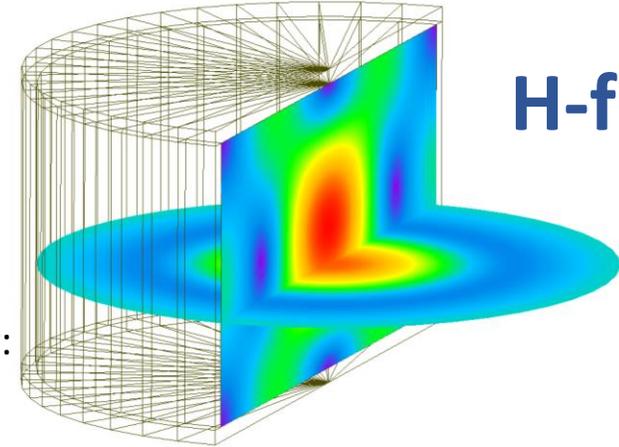
Measurement problems are **deterministic** (cavity is **coupled** to source & load).

Cylindrical resonator: single-mode versus multi-mode operation

TE011 mode



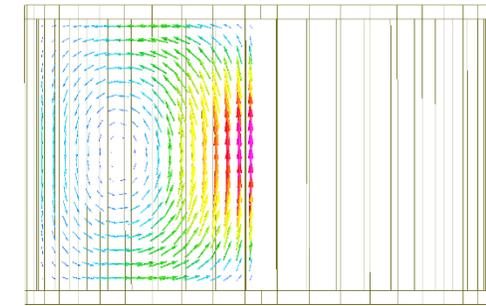
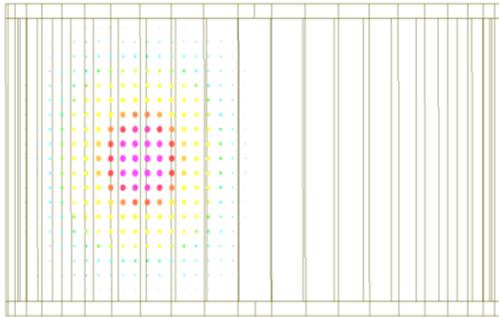
E - field



H-field

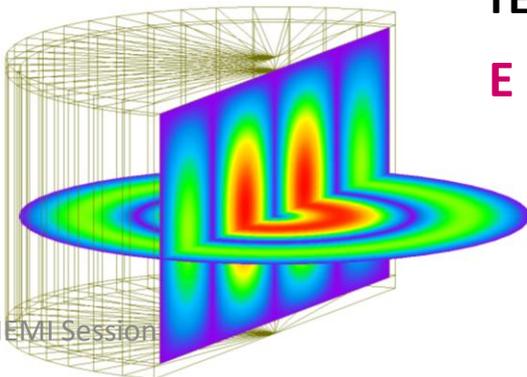
compared to rectangular (cuboidal) cavities, typically:

- lower contribution of wall losses
- easier standard manufacturing



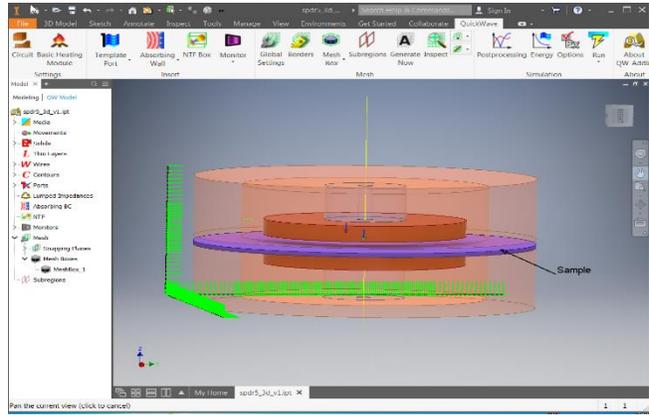
TE021 mode

E - field

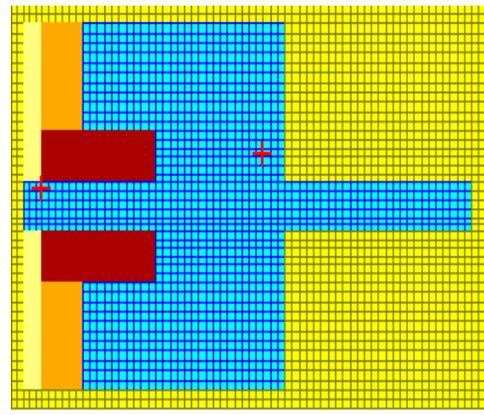


- ❑ Resonators are **multimode** devices hence formally, material measurement can be performed at **many frequencies** in the same resonator.
- ❑ **Some modes provide highest accuracy** of material characterization. Some are difficult to excite.
- ❑ Software provided with the resonator is compatible only with modes pre-selected by the vendor.
- ❑ **Single mode resonators: SPDR, SCR**
- ❑ **Multi-mode resonators: BCDR and FPOR.**

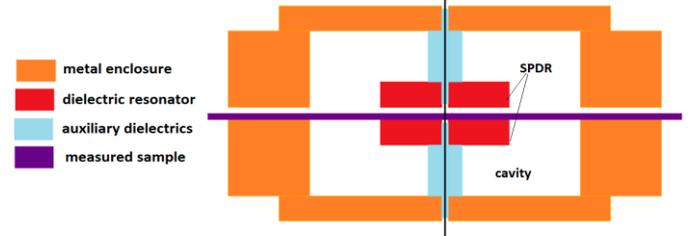
Split-Post Dielectric Resonator (SPDR) - basics



Full 3D model of 10GHz SPDR in QW-AddIn for Autodesk® Inventor® Software (common environment for modelling & manufacturing)



Axisymmetrical 2D BOR model full EM information economies in computer effort : 10^3 or more

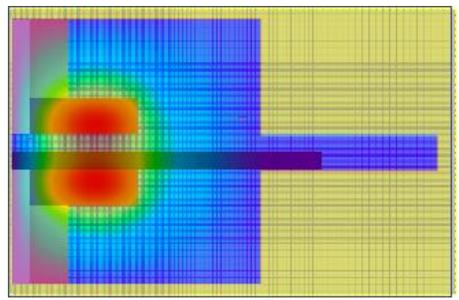


For laminar dielectrics and high-resistivity semiconductors

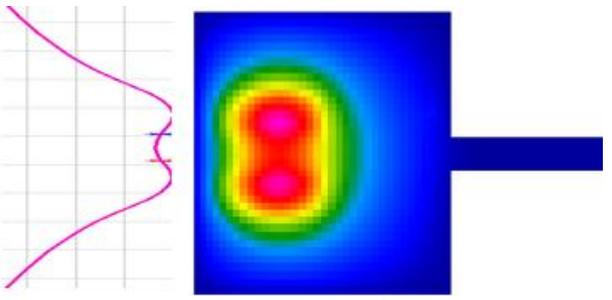
- resonant mode with EM fields mostly confined in and between those ceramic posts
- Field patterns remain practically unchanged but resonant frequencies and Q-factors change, providing information about SUT material parameters

SUT of $\epsilon_s = \epsilon_s' - j\epsilon_s''$ is inserted into DR: resonant frequency changes from f_e to f_s and Q-factor changes from Q_e to Q_s .

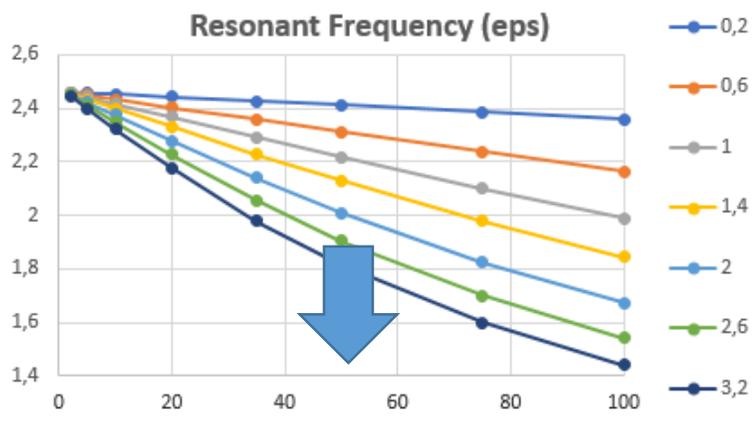
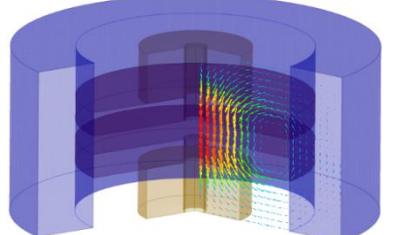
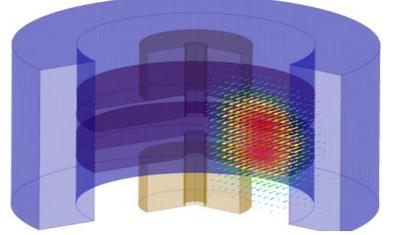
Sample in strong E-field nearly constant between the two posts



Electric field



Magnetic field



QuickWave simulations of 2.5GHz SPDR performed in automatic Parameter Sweep for varying sample thickness (colours) and dielectric constant (eps)

Data for dedicated software for material parameters extraction



Split-Post Dielectric Resonator (SPDR) – operation

Operation workflow – with the use of Q-Meter

0. Connect the SPDR to Q-Meter using SMA cables. Connect Q-Meter to PC using USB cable.

1. Measure “empty SPDR” – app invoked measurement.

2. Measure thickness of the sample

3. Insert the sample into SPDR

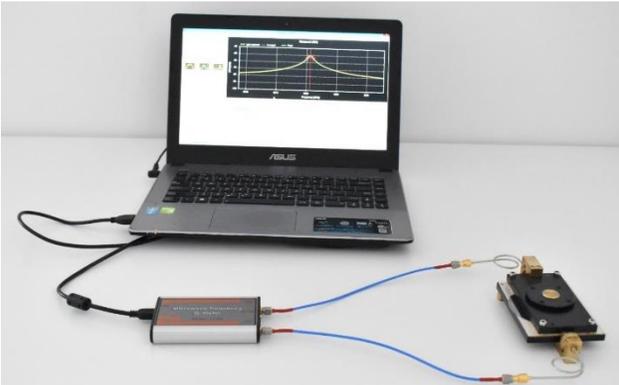
4. Insert the sample thickness into the PC app

5. Material parameters are extracted automatically

Total measurement time: 30sec



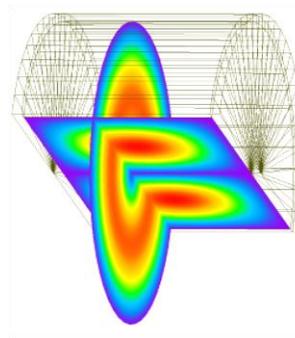
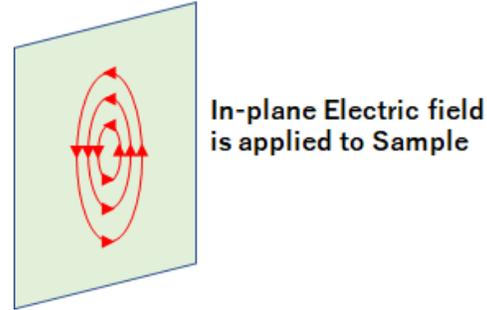
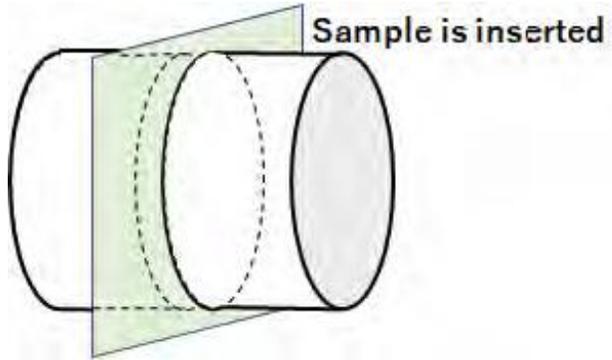
SPDR use in labs...
...and at home



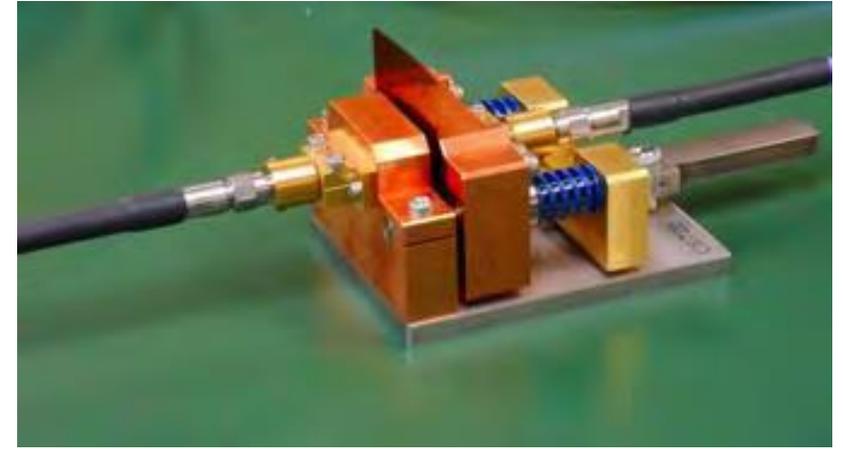
For many practical materials, measuring only abs (S21) provides appropriate accuracy.

Keysight Option N1500A uses S21 (amplitude & phase) which helps enhance accuracy (under study in iNEMI project)

Split Cylinder Resonator (SCR) – basics & operation

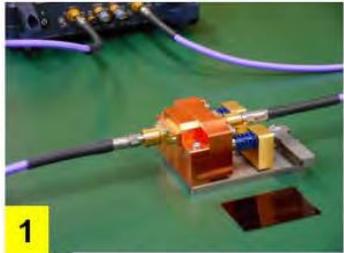


TE011 mode



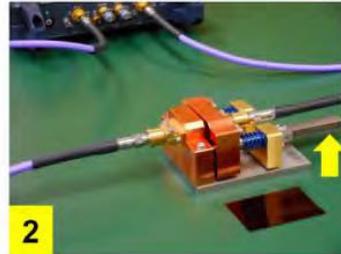
Operation workflow

Connect the cables and measure.
No need for other preparation or calibration.

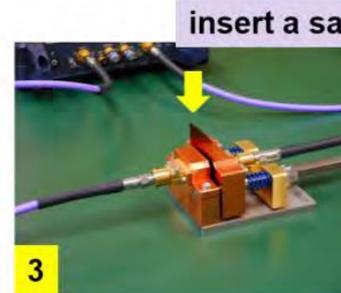


measure "empty"

10 sec



open the lever



insert a sample

15 sec



close the lever and measure

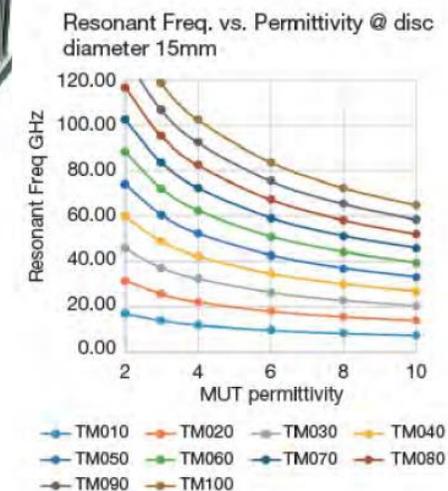
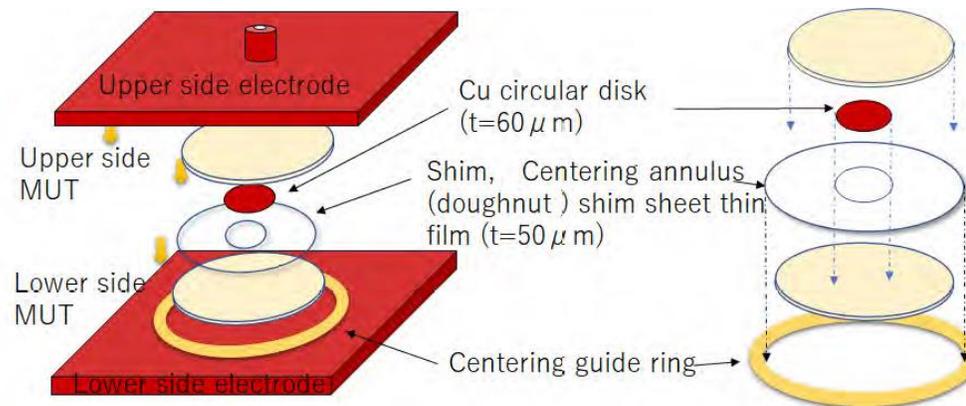
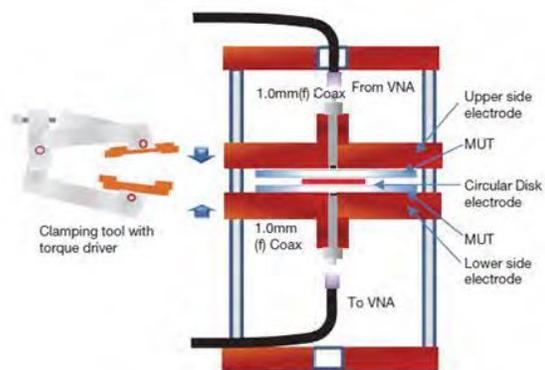
Very efficient measurement cycle for high volume measurements.

Same measurement results regardless who uses it.

Discrete frequency points from 10 GHz up to 80 GHz

- High measurement precision
- Can be sensitive to many user errors
- Typically interpolated to 5G mmWaves
- Typically in-plane component of permittivity
- Typical sample thicknesses around 100 um
- Support temperature sweep measurement
- IPC-TM-650 2.5.5.13
- <https://www.keysight.com/us/en/assets/7018-06384/brochures/5992-3438.pdf>

Balanced-type circular disk resonator (BCDR) – basics & operation



Operation workflow



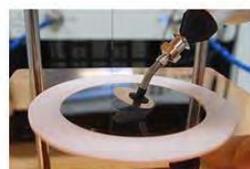
Open the resonator



Set lower side sample



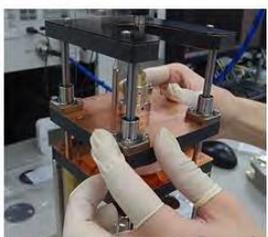
Set shim sheet



Set center electrode



Set upper side sample



Close the resonator



Clamp and measure

Multiple discrete frequency points from 10 GHz up to 120 GHz

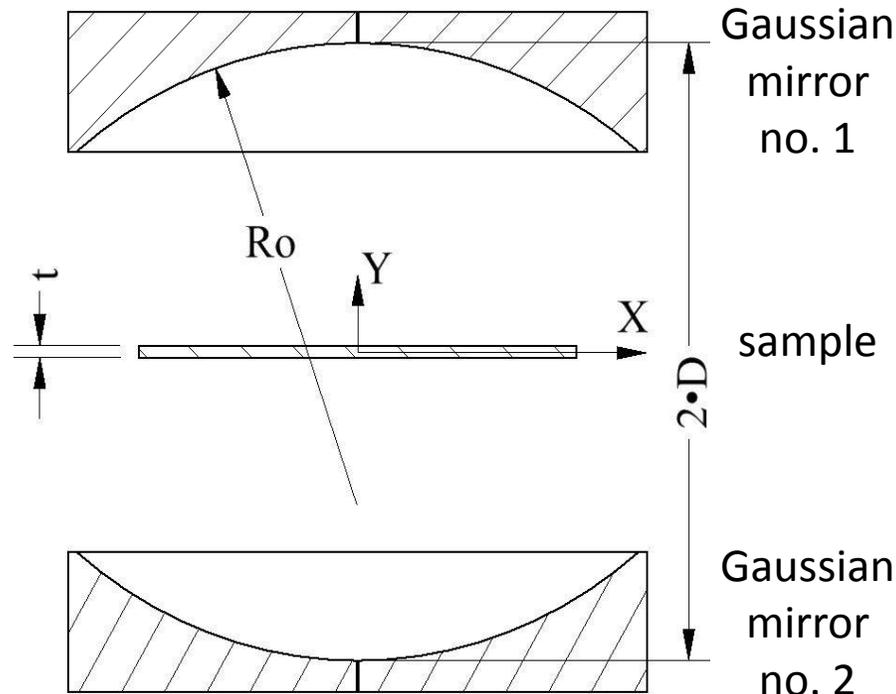
- High measurement precision
- Requires full 2-port calibration (mechanical to 110 GHz or electrical to 67 GHz)
- Typically out-of-plane component of permittivity
- Typical sample thicknesses less than 1 mm
- IEC 63185
- <https://www.keysight.com/us/en/assets/7120-1214/flyers/N1501AE11-67-Balanced-Type-Circular-Disk-Resonator-BCDR.pdf>

Millimetre-wave characterisation of dielectric materials

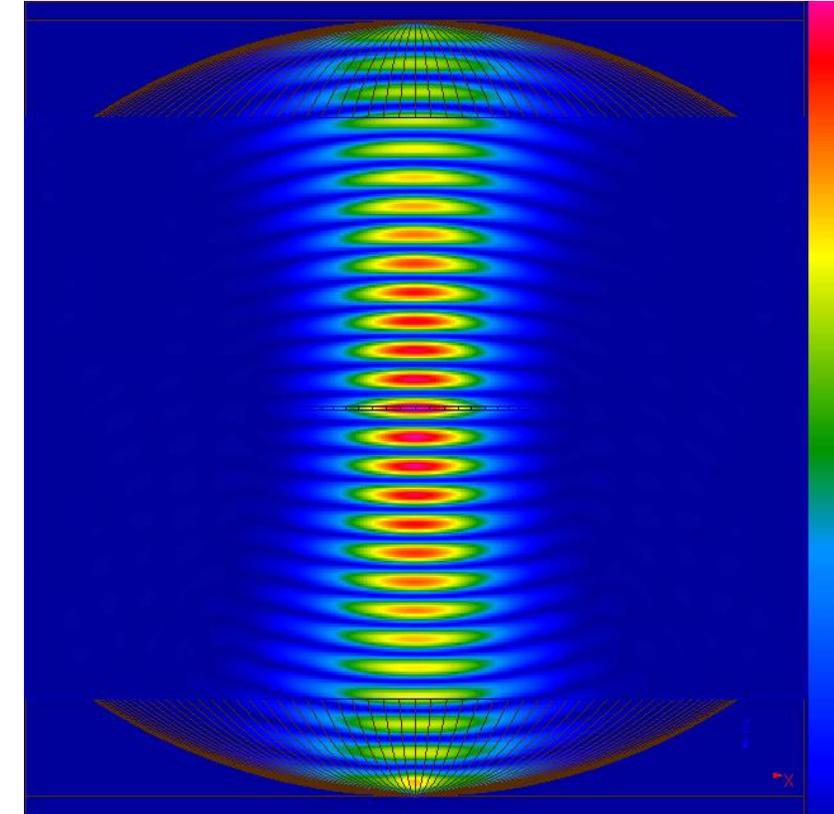
Fabry-Perot Open resonator



Bridging the gap between classical resonant methods and free space methods



Gaussian TEM_{00q} modes



Electric field distribution - simulation model in QuickWave software

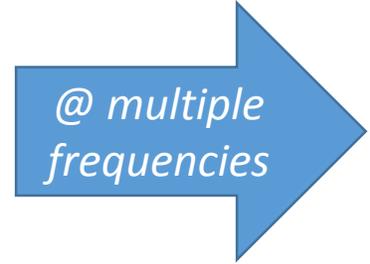
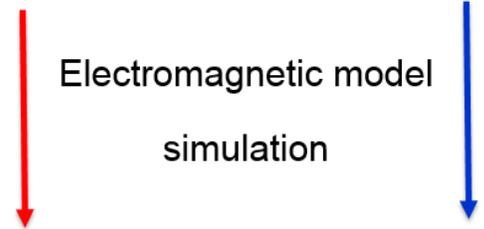
- Single device
- Spectrum: 20-110 GHz
- Frequency resolution: ca. 1.5 GHz
- Dk accuracy: $\Delta\epsilon/\epsilon < 0.5\%$
- Df range: $10^{-5} < \tan\delta < 10^{-2}$
- Sample diameter: > 3 inches
- Sample thickness: < 2 mm
- Fully automated measurement: (ca. 10 minutes in 20-50GHz)

Fabry-Perot Open Resonator (FPOR) – measurement concept



Measurement:

Resonant frequency and Q factor



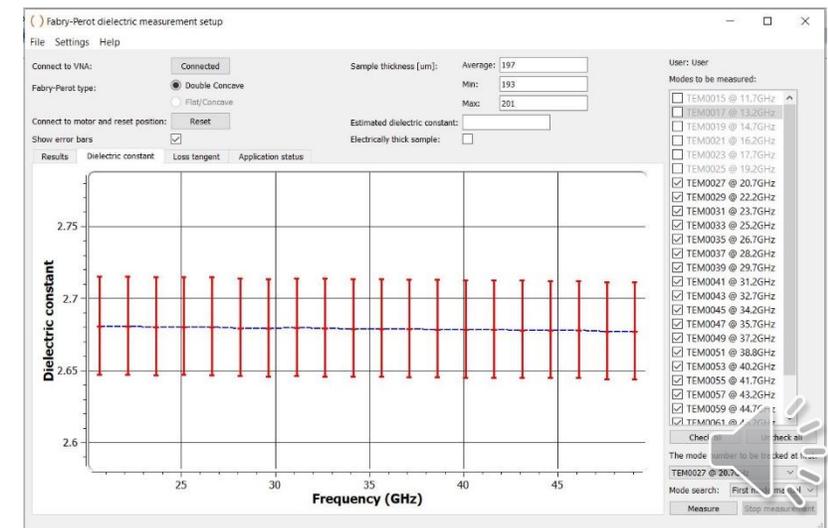
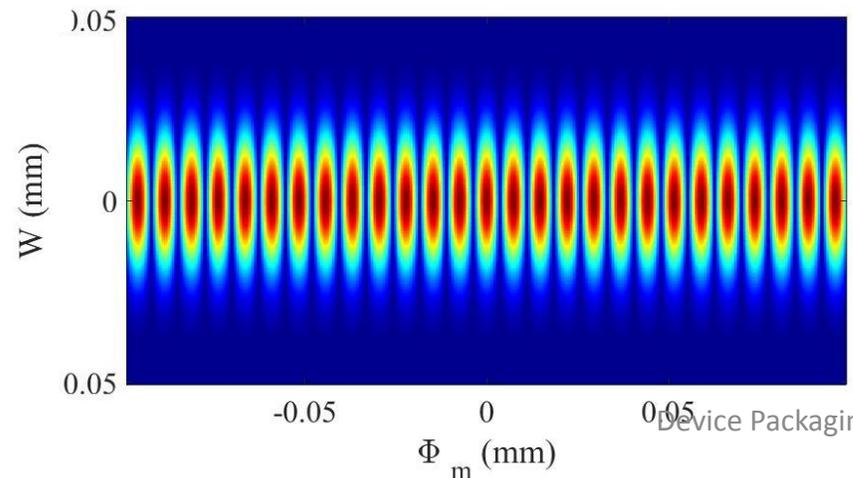
Dielectric constant and loss tangent

Challenges for user

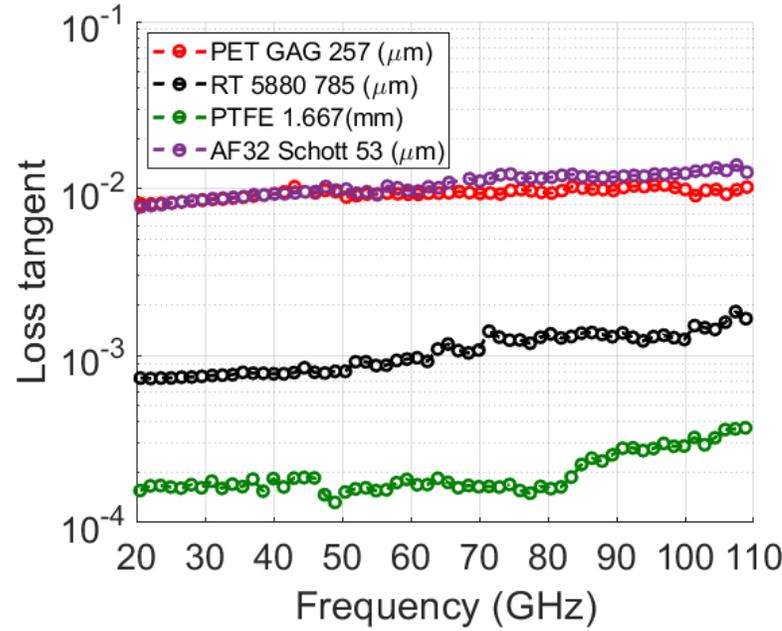
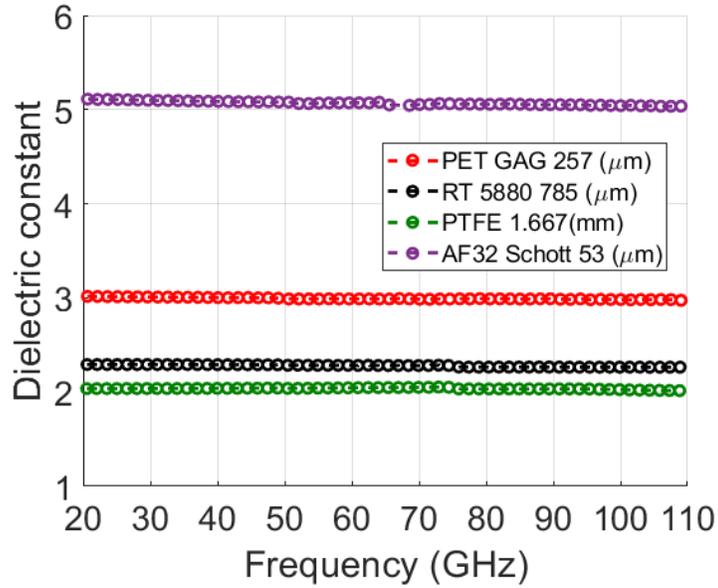
- mode identification
- mode tracking among plenty of other modes occurring in the FPOR

Solution

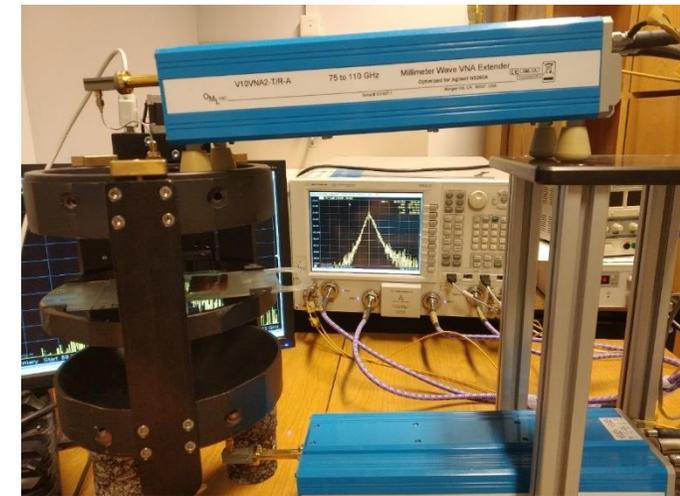
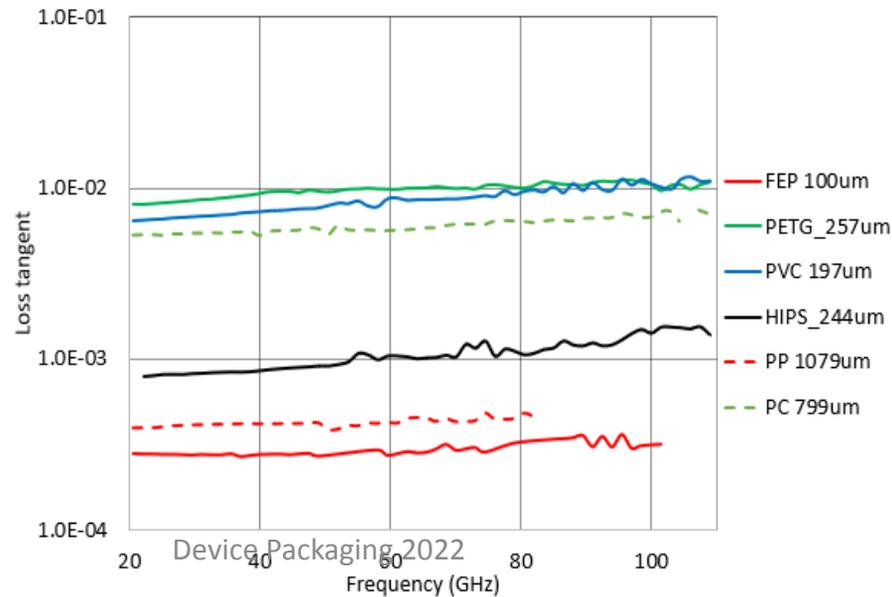
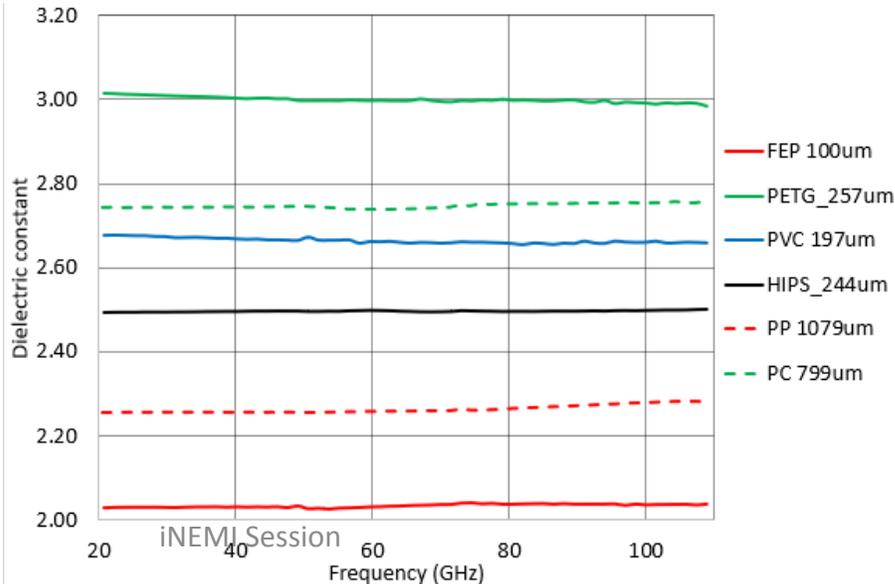
- Dedicated control software
- Automatic adaptive mode tracking algorithm
- No user intervention needed



Fabry-Perot Open Resonator (FPOR) – results



FPOR with a polystyrene (HIPS) sample placed on a sample holder



FPOR with OML frequency extenders operating in 75-110 GHz range.



5G/mmWave Materials Assessment and Characterization



Project Task3

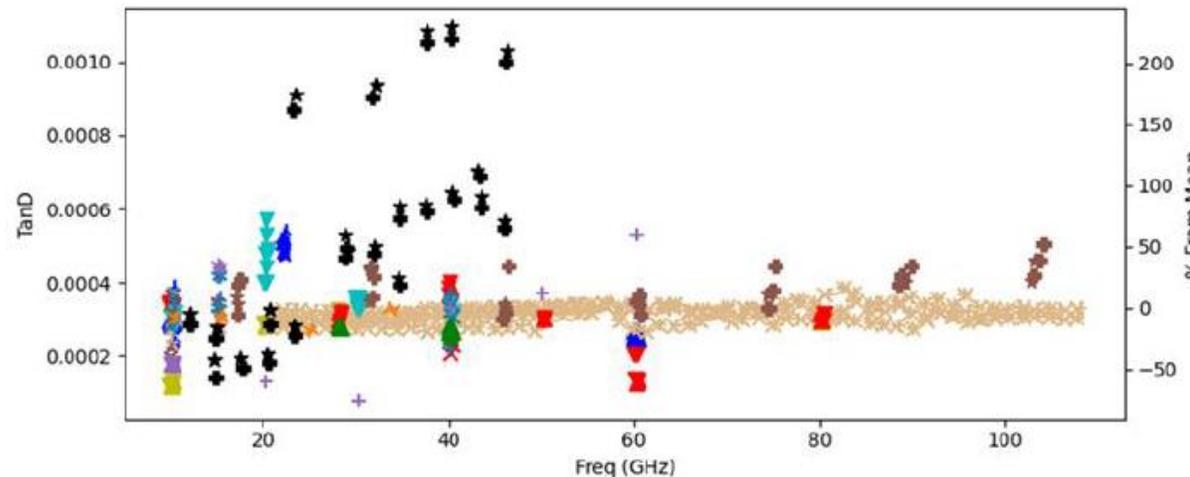
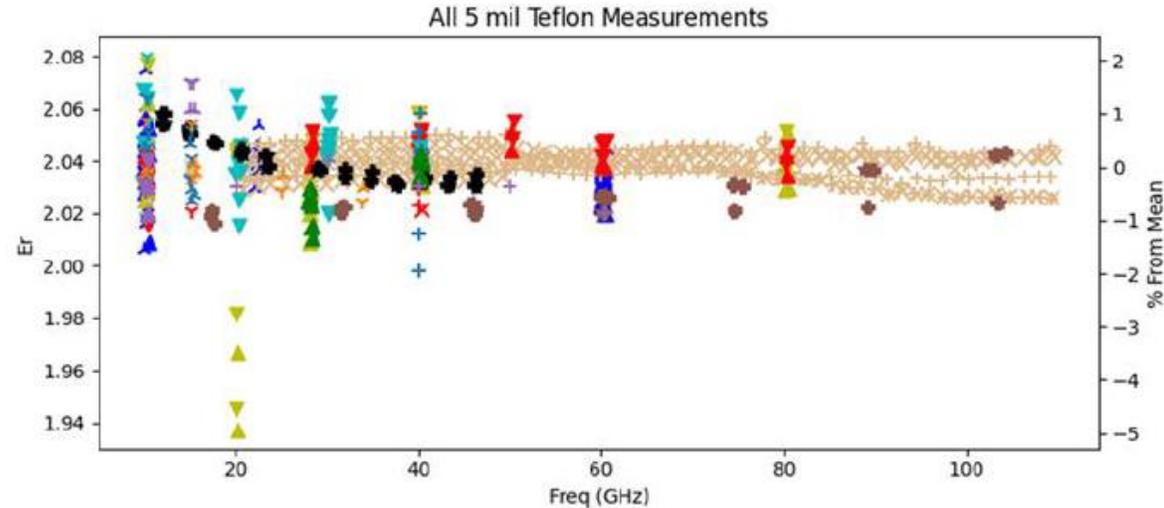
❑ Benchmarking popular measurement techniques on known material samples

❑ 3 material types

❑ 12 samples (6 in each of two sizes: 35x45mm, 90x90mm)

❑ 10 samples kits

❑ 11 labs

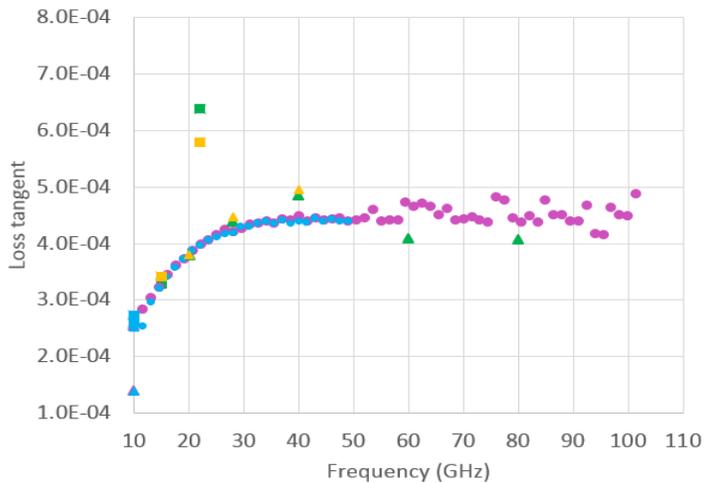
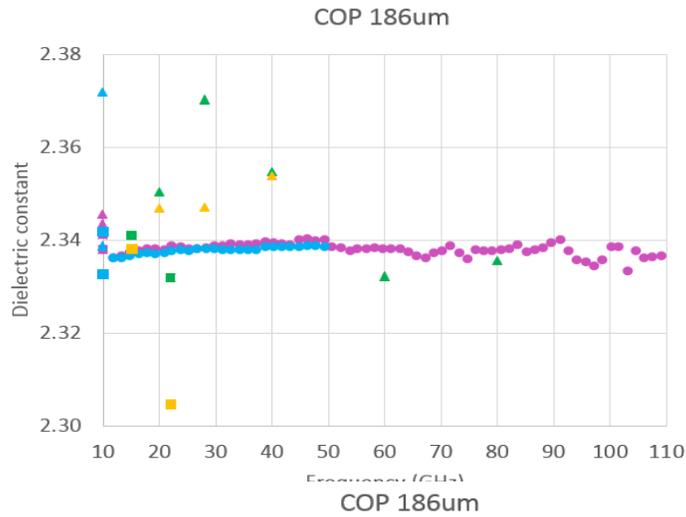


- ▲ Intel SPDR(i)
- ▲ Intel SCR(i)
- ▼ Keysight SCR(L)
- ▲ Keysight SCR(i)
- ▼ Keysight SCR85072(i)
- ▼ Keysight SCR85072(L)
- ▲ QWED SPDR(i)
- ▼ QWED SPDR(L)
- × QWED FabryPerot(i)
- + QWED FabryPerot(L)
- ▼ ITRI SCR(L)
- ▲ ITRI SCR(i)
- ▼ ITRI SPDR(L)
- ▲ ITRI SPDR(i)
- ▼ ITRI SCR85072(L)
- × ITRI FabryPerot(i)
- + ITRI FabryPerot(L)
- ▼ ITEQ SCR(L)
- ▼ ITEQ SPDR(L)
- Nokia BCDR(i)
- ★ Nokia BCDR(L)
- ▲ Shengyi Electric SPDR(i)
- ▼ Shengyi Electric SPDR(L)
- × Shengyi Electric FabryPerot(i)
- + Shengyi Electric FabryPerot(L)
- ▲ Showa Denko SPDR(i)
- ▼ Showa Denko SPDR(L)
- Showa Denko BCDR(i)
- ★ Showa Denko BCDR(L)
- ▲ NIST SCR(i)
- ▼ 3M SPDR(L)
- ▲ 3M SPDR(i)
- ▼ Dupont SCR(L)
- ▲ Dupont SCR(i)
- ▼ Dupont SPDR(L)
- ▲ Dupont SPDR(i)
- + Dupont FabryPerot(L)



Project Task3

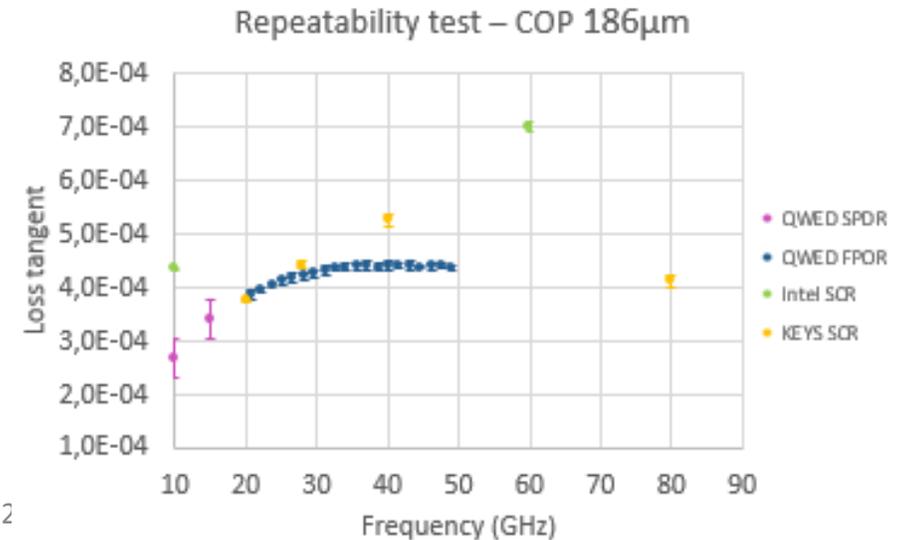
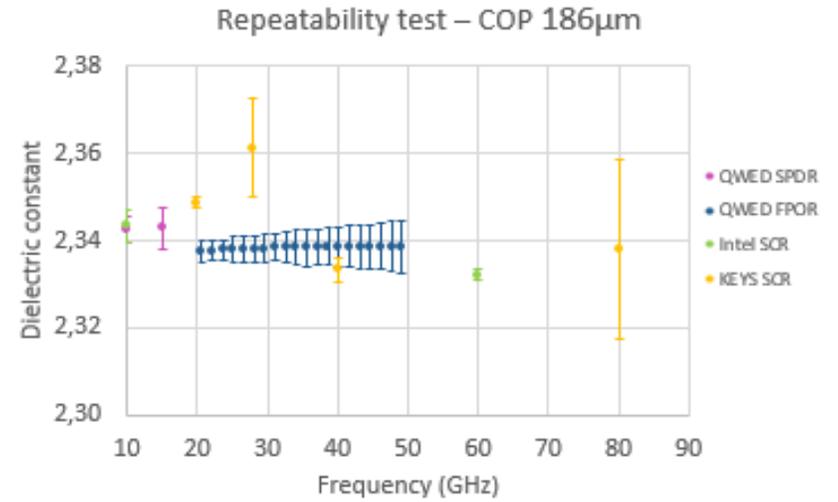
Measurements



Task 3 Report

Task 4

Repeatability and reproducibility studies



*M. Celuch et al. "Bridging the materials' permittivity traceability gap for 5G applications", IEEE Antennas & Propagation Symposium, 2021.

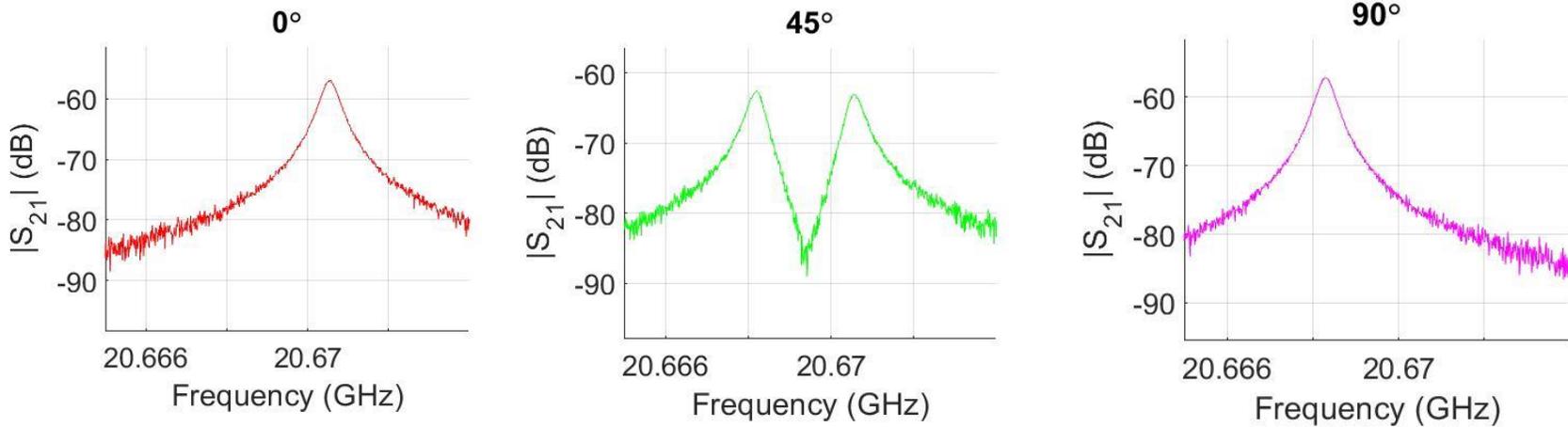
Project Task4

- ❑ Industry samples provided by the members of Project Consortium
- ❑ 2 types of material samples: electronic and automotive
- ❑ Challenges in handling thin samples (e.g. fused silica)
- ❑ Challenges in measuring thick automotive samples
- ❑ Over 50 samples in total
- ❑ 5 labs
- ❑ 4 measurement techniques
- ❑ In the middle of the task completion

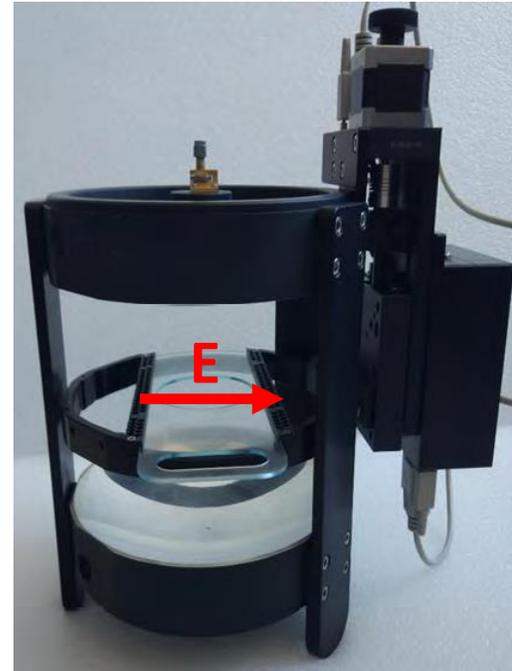


Fabry-Perot Open Resonator (FPOR) – in-plane anisotropy

With appropriately designed feeding loops, FPOR is capable of **linear E-field polarization** and hence **detecting in-plane anisotropy**:

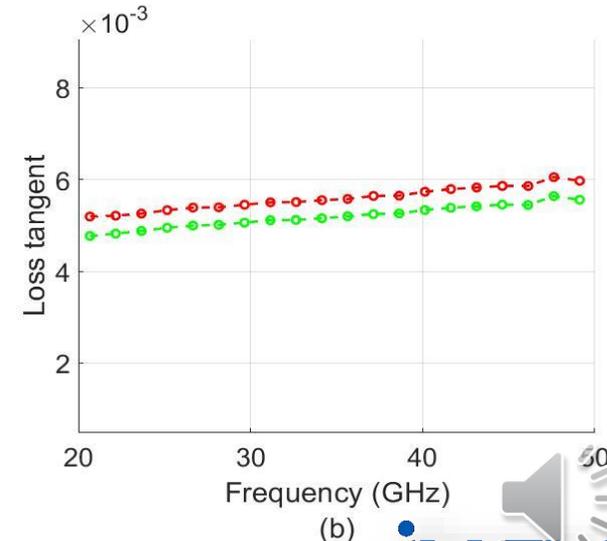
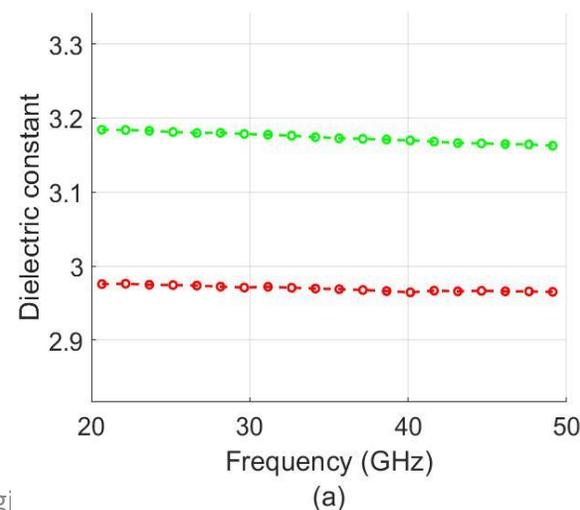


Resonances detected for **BoPET** sample ($t = 0.100$ mm), turned in xy plane.



BoPET (biaxially-oriented PET) involves thermal drawing in two in-plane directions with substantially different draw ratios, followed by **crystallization**. Hence, it is **in-plane anisotropic**.

For **PETG** (non-crystalline copolyesters, **isotropic**), resonant frequency does not depend on angular position of the sample.



Task 4 additional activity: 2D imaging of material parameters



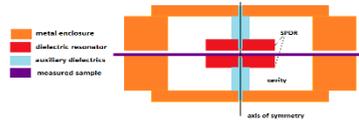
- ❑ 2D maps of electrical parameters: *relative permittivity* (D_k), *loss tangent* (D_f), *resistivity*, or *surface resistance*
- ❑ Material homogeneity testing
- ❑ For qualitative and quantitative material testing
- ❑ Laminar dielectrics – packaging in 5G systems
- ❑ Semiconductors industry – high density packaging at a single wafer
- ❑ Battery cells materials – uniformity of electrical parameters of anodes



2D imaging of material parameters – laminar dielectrics (1)

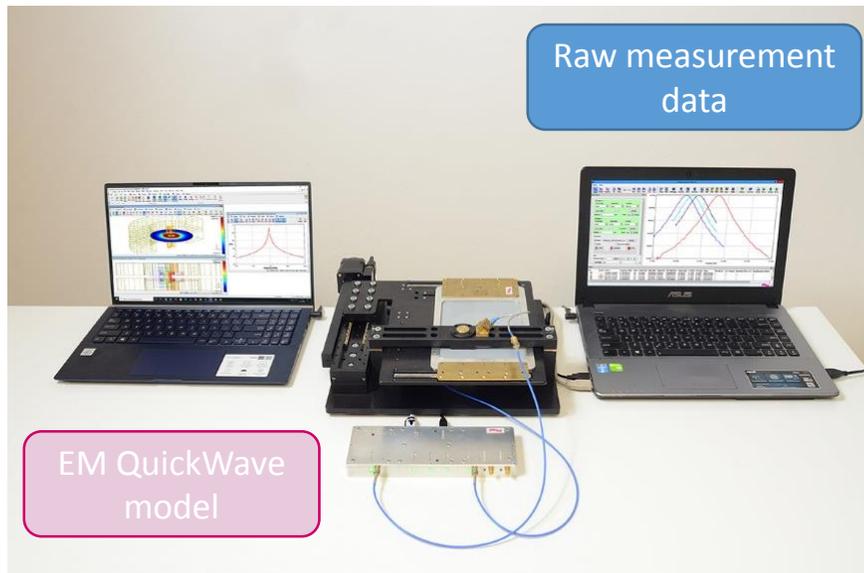


For low-loss dielectrics and high-resistivity semiconductors



- ❑ SPDR technique based 2D scanner
- ❑ Simulation model accounting for mechanical constraints, e.g. dielectric membrane serving as sample holder
- ❑ 10GHz for higher spatial resolution

A joint product of QWED and Keysight, developed in the H2020 MMAMA project, has been acknowledged as *Innovation Radar* of the European research.



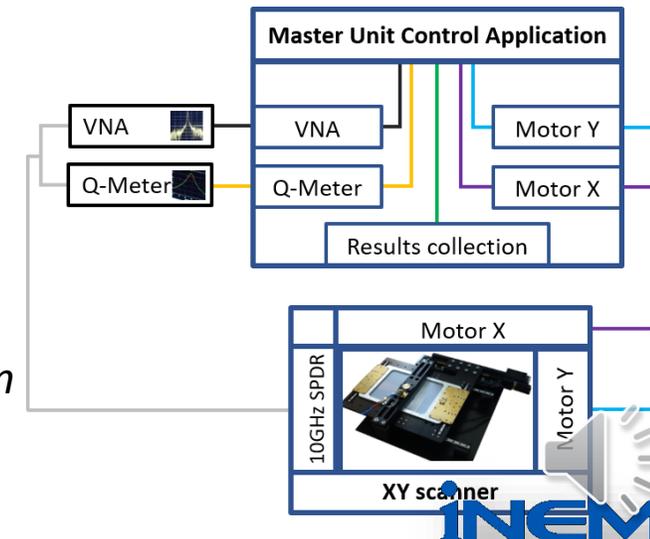
EM QuickWave model

Raw measurement data

$|S_{21}|$ curves are for several scanning positions:

- curve max indicates resonant freq. (Dk)
- curve 3dB width indicates losses (Df)

Fully automated measurement procedure through control application



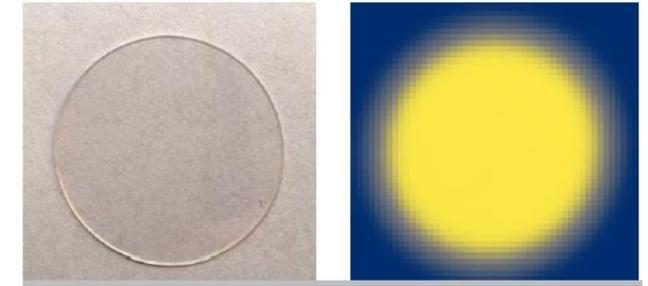
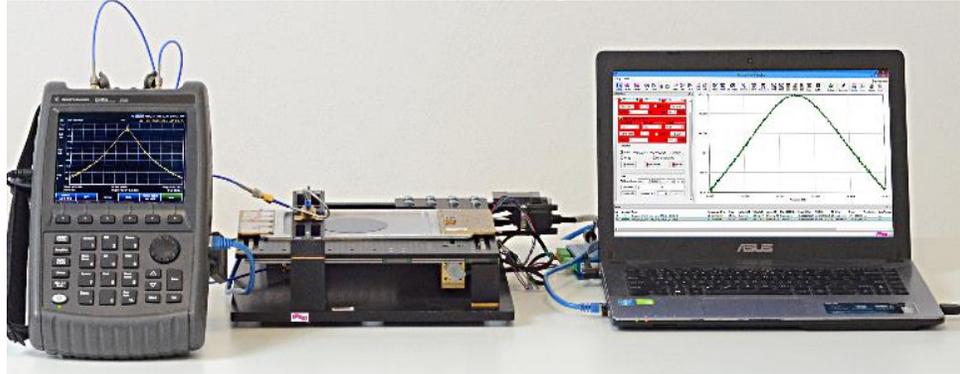
2D imaging of material parameters – laminar dielectrics (2)



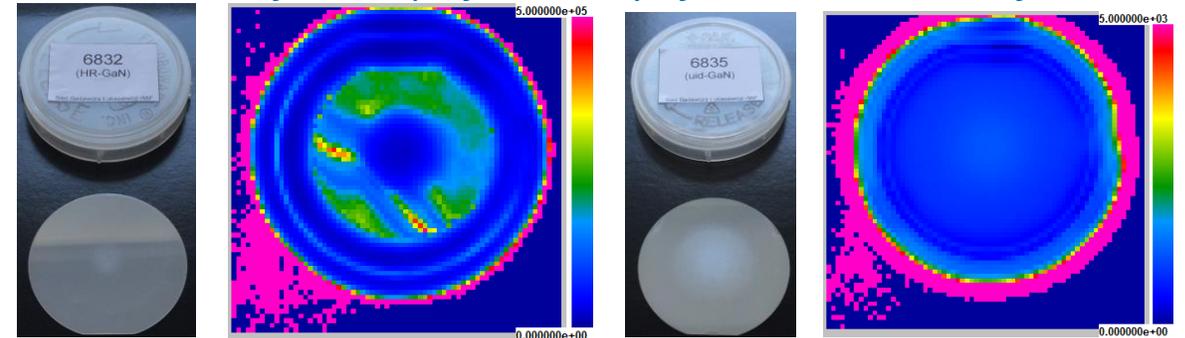
For low-loss dielectrics and high-resistivity semiconductors

2D surface map of dielectric constant of quartz

2D SPDR scanner @ 10GHz

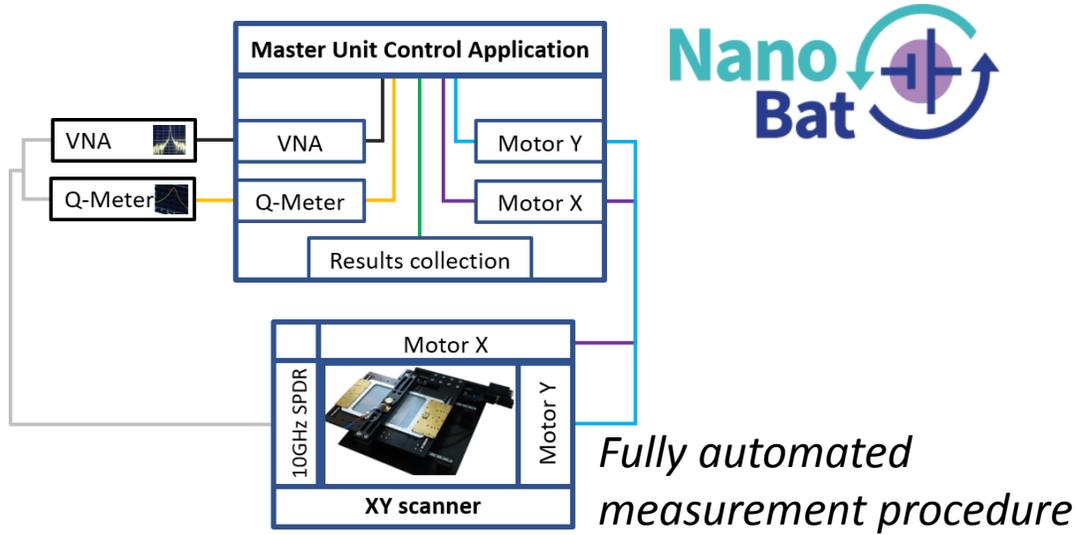


2D surface map of resistivity of semiconductor wafers

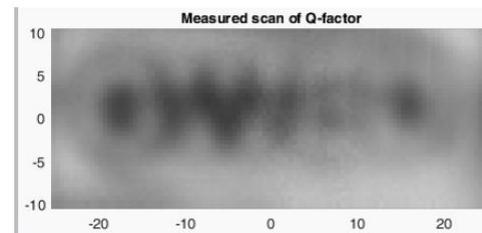


*courtesy L-IMP, Poland

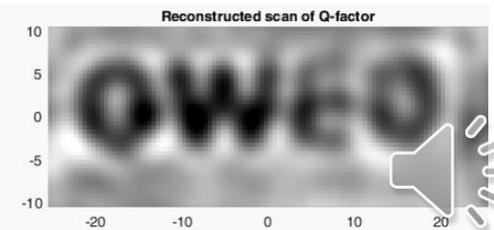
2D surface map of measured Q-factor of „QWED” pattern made of organic semiconductor deposited on quartz



Raw data image

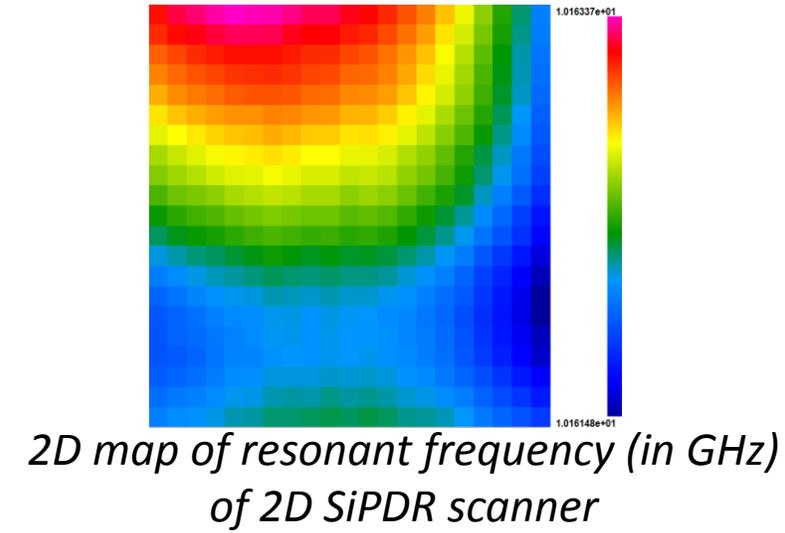


Data post-processed using field pattern simulated in QuickWave



*courtesy MateriaNova, Belgium

2D imaging of material parameters – conducting materials



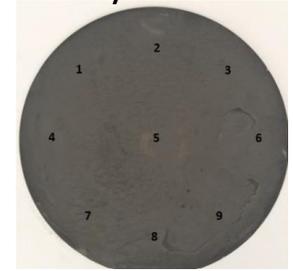
Motorised 2D surface scanner based on SiPDR

VNA
*courtesy Keysight Technologies, Austria

Scanner Unit Control App

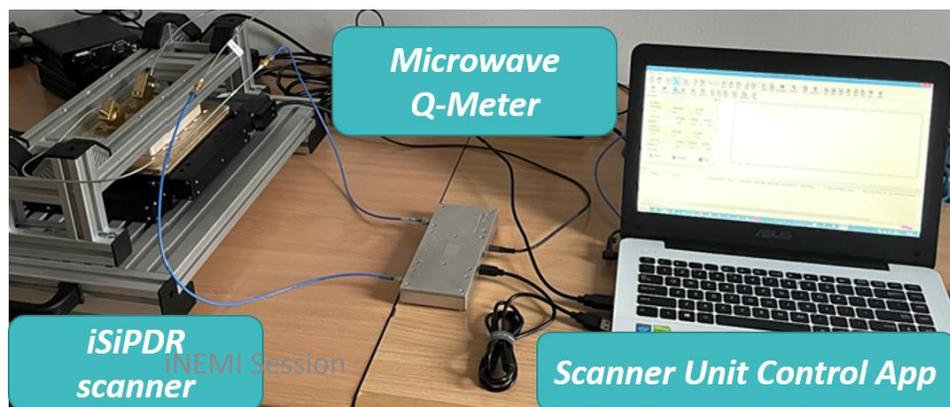
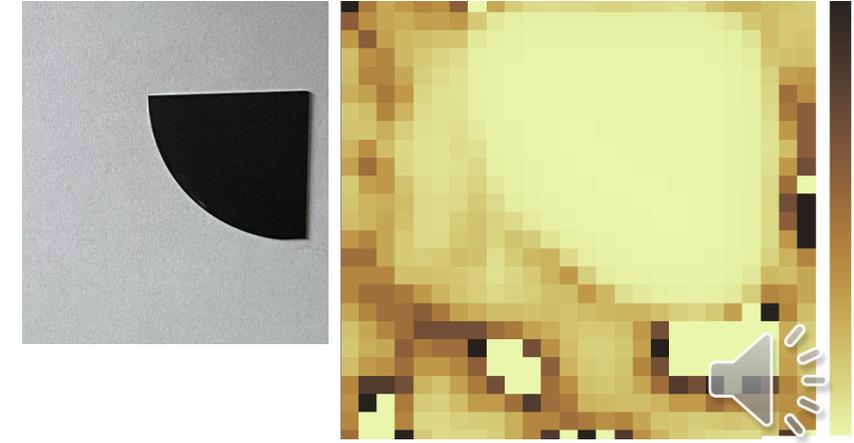


Graphene –based battery anode



*courtesy PLEIONE Energy, Greece
Device Packaging 2022

Semiconductor sample and its 2D resistivity map



iSiPDR scanner

Scanner Unit Control App

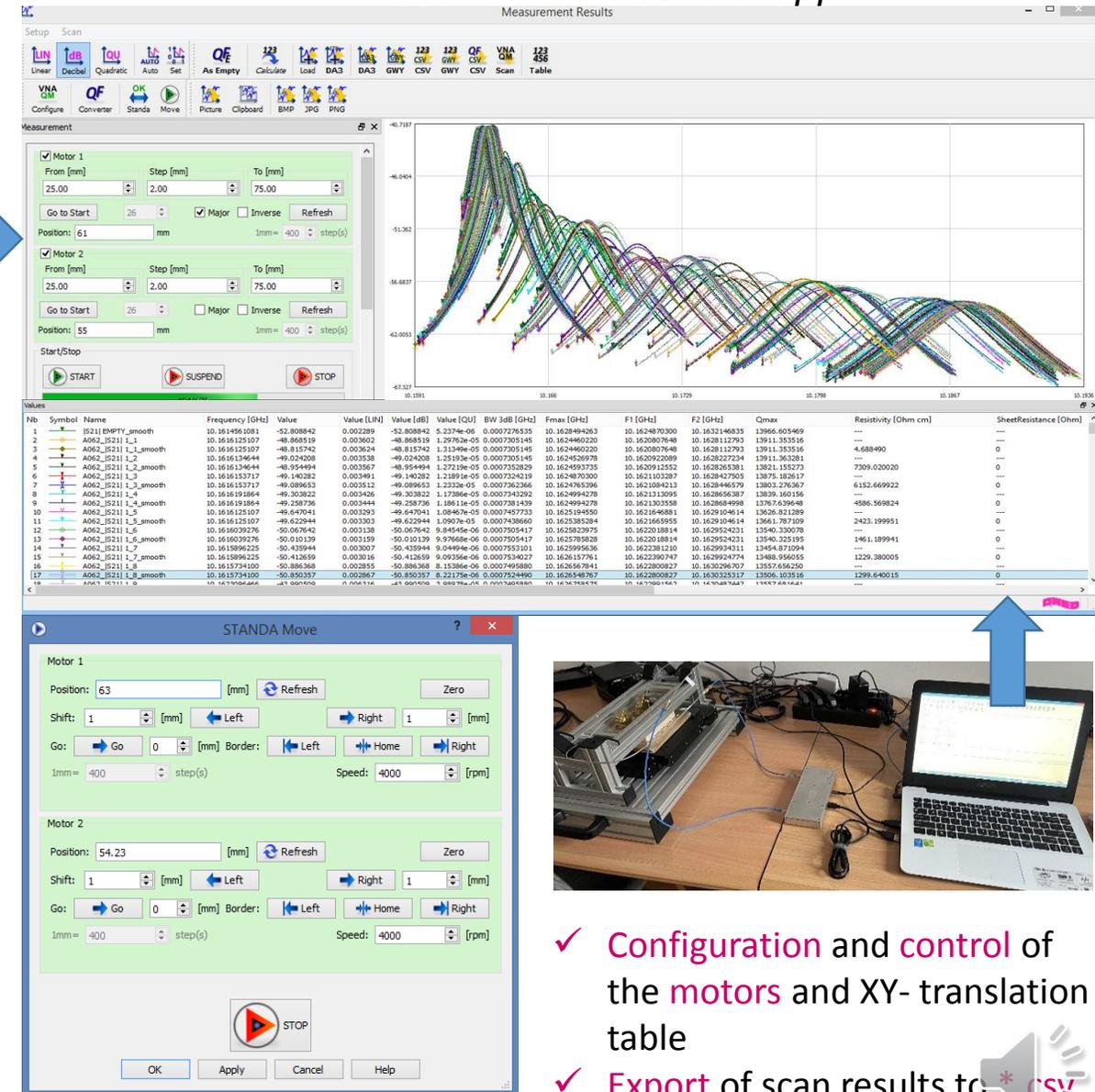
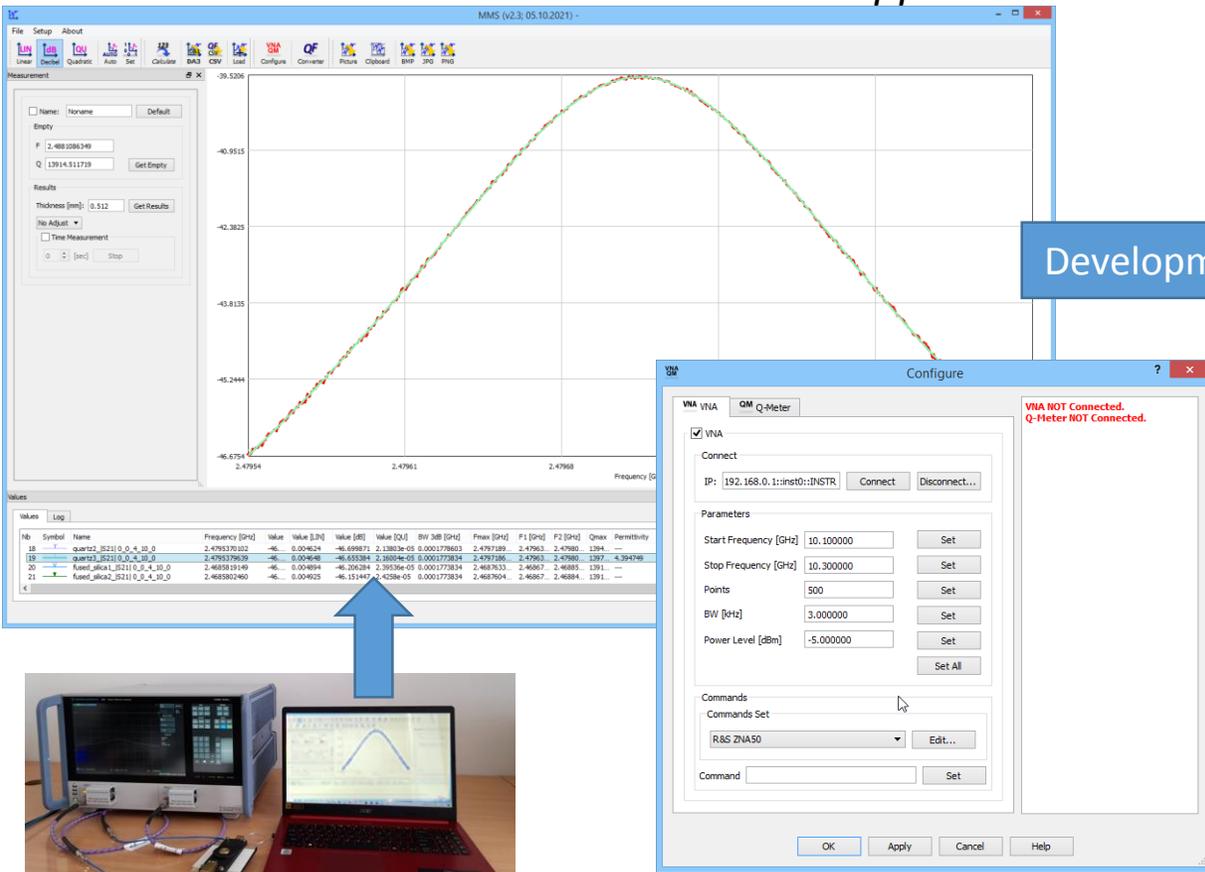
Dedicated measurement control software



SPDR & SiPDR measurement control app

Scanner Unit Control app

Development



- ✓ Fully automated measurement procedure
- ✓ VNA/Q-Meter configuration, communication & control
- ✓ Built-in procedure for enhanced accuracy of Q-factor extraction
- ✓ Material parameters extraction
- ✓ Visualisation of measured material parameters values
- ✓ Import/export options

- ✓ Configuration and control of the motors and XY- translation table
- ✓ Export of scan results to *.csv and industrial *.gwy formats

Ultra-Low Temperature Co-fired Ceramics for 6th Generation Electronic Packaging

ULTCC6G_EPac« M-ERA-NET Joint Project Ref CEA : X40955

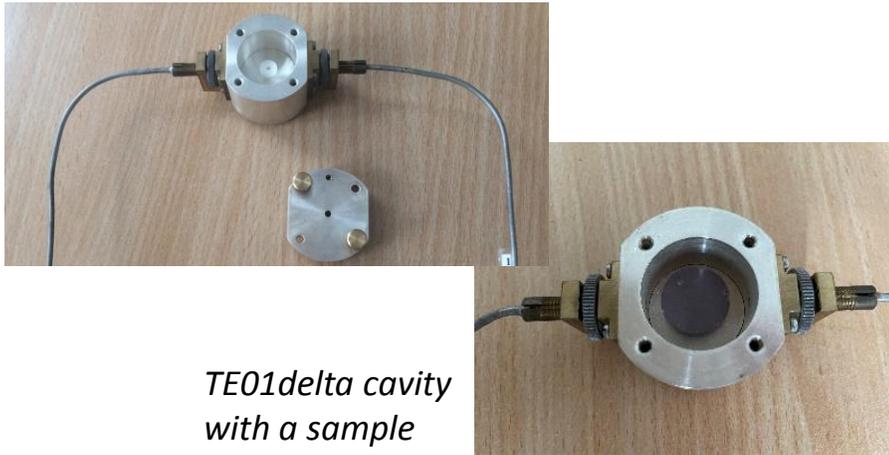


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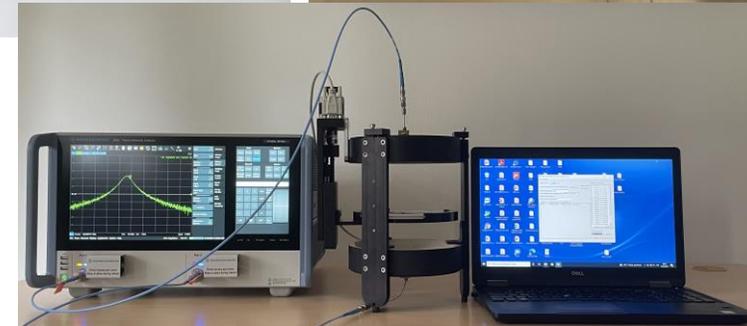
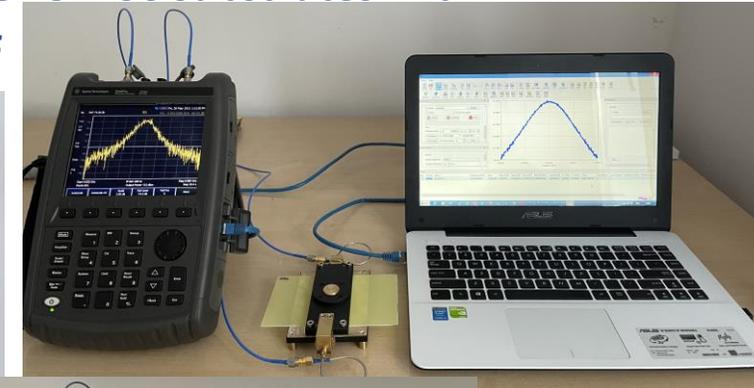


Measurements of multilayer ULTCC substrates with SPDR and FPOR techniques

Measurements of bulk ULTCC composites



TE01delta cavity with a sample



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(website: www.nanobat.eu)



Simulations conducted with **QuickWave EM software**, developed & commercialised by QWED.

The original designs of QWED resonators for material measurements from **Prof. Jerzy Krupka**, e.g.:

J. Krupka, A. P. Gregory, O. C. Rochard, R. N. Clarke, B. Riddle, and J. Baker-Jarvis, "Uncertainty of complex permittivity measurements by split-post dielectric resonator technique", *J. Eur. Ceramic Soc.*, vol. 21, pp. 2673-2676, 2001.

J. Krupka and J. Mazierska, "Contactless measurements of resistivity of semiconductor wafers employing single-post and split-post dielectric-resonator techniques," *IEEE Trans. Instr. Meas.*, vol. 56, no. 5, pp. 1839-1844, Oct. 2007.

THANK YOU!

